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AFH :

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KIRA, et al.**

Group Art Unit: **2822**

Serial No.: **08/897,953**

Examiner: **David E. GRAYBILL**

Filed: **July 24, 1997**

P.T.O. Confirmation No.: 5157

For: **METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE**

AMENDMENT UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2822

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 12, 2006

Sir:

In response to the Final Office Action dated **June 14, 2006**, please amend the above-identified application as follows: